

03-29-2000

In place of Form PTO-1595

Docket No. 12179-P086US



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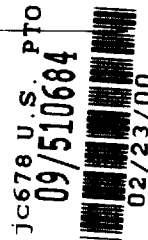
To the Assistant Commissioner of Patents: Please record the attached original documents or copy thereof.

1. Name of conveying party(ies):

Zhidan L. Tolt

2. Name and address of receiving party(ies):

SI Diamond Technology, Inc.
3006 Longhorn Blvd., Suite 107
Austin, Texas 78758



3. Nature of conveyance:

X Assignment

Execution Date: February 18, 2000

4. Application number(s) or patent number(s):

If this document is being filed together with a new application, the execution date of the application is February 18, 2000

A. Patent Application No.(s)

09/510684

B. Patent

5. Name and address of party to whom correspondence concerning document should be mailed:

Kelly K. Kordzik
Winstead Sechrest & Minick P.C.
5400 Renaissance Tower
1201 Elm St.
Dallas, TX 75270-2199
(512) 370-2851

6. Total number of applications and patents involved: 1

7. Total fee (37 CFR 3.41) \$ 40.00

 Authorized to be charged to deposit account
X Check enclosed

8. Deposit account number:

03/28/2000 DCOATES 00000052 09510684

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9. Statement and signature.

To the best of my knowledge and belief, the foregoing information is true and correct and any attached copy is a true copy of the original document.

Kelly K. Kordzik

Name of Person Signing

Signature

2/23/00

Date

Total number of pages including cover sheet: 2

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207:12179-P086US

A S S I G N M E N T

Whereas, I,

(1) Zhidan L. Tolt of San Jose,
County of Santa Clara and State of California,

have invented certain improvements in

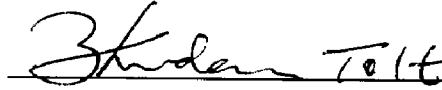
A SUBSTRATE SUPPORT FOR USE IN A HOT FILAMENT
CHEMICAL VAPOR DEPOSITION CHAMBER

and executed, respectively, a United States patent application therefor on (*Dates Inventors Signed Declaration*) (1) 2-18-00.

Whereas, SI DIAMOND TECHNOLOGY, INC., a corporation of Texas, having a place of business at 3006 Longhorn Blvd., Suite 107, Austin, Texas 78758 (hereinafter called SIDT), desires to acquire the entire right, title and interest in the said application and inventions, and to any United States and foreign patents to be obtained therefor;

Now, therefore, for a valuable consideration, receipt whereof is hereby acknowledged, we, the above named, hereby sell, assign, and transfer to SIDT, its successors and assigns, the entire right, title and interest in the said application and inventions therein disclosed for the United States and foreign countries, and all rights of priority resulting from the filing of said United States application, and we request the Commissioner of Patents to issue any Letters Patent granted upon the inventions set forth in said application to SIDT, its successors and assigns; and we hereby agree that SIDT may apply for foreign Letters Patent on said inventions and we will execute all papers necessary in connection with the United States and foreign applications when called upon to do so by SIDT.

(1) Signed at San Jose, California, on Feb. 18, 2000.



Zhidan L. Tolt